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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Reissue Application of: Shunichi SATO

Reissue Application No.: 10/603,418

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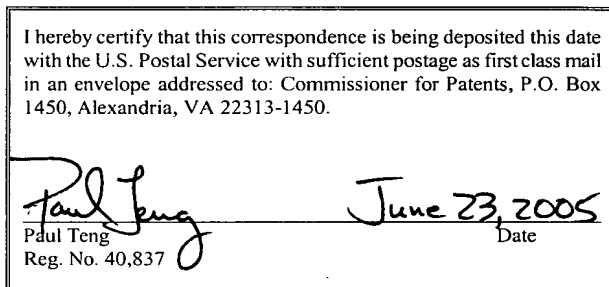
Original Patent No.: 5,904,549

Granted On: May 18, 1999

For: METHODS FOR GROWING SEMICONDUCTORS AND DEVICES THEREOF
FROM THE ALLOY SEMICONDUCTOR GAINNAS

Examiner: Laura M. Schillinger

Group Art Unit: 2813



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Sir:

AMENDMENT

This Amendment is submitted in response to the Office Action dated March 23, 2005 in connection with the above-identified application.

Amendments to the claims are reflected in the **Listing of Claims** section which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

A copy of the Ohkouchi paper is attached hereto as **Exhibit A**.

A Form PTO-1449 is attached hereto as **Exhibit B**.